Customer No.: 31561 Docket No.: 12739-US-PA Application No.: 10/710,698

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: SALZMAN, KOURTNEY R
Group Art Unit: 1795

In re PATENT APPLICATION of
Applicants: Chen et al.
)
Serial No.: 10/710,698
)
Filed: July 29, 2004
)
For: PHYSICAL VAPOR
DEPOSITION PROCESS AND
APPARATUS THEREFOR
)
Attorney Docket: 12739-US-PA

The Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 12739-US-PA).

PRELIMINARY AMENDMENT

United States Patent and Trademark Office
Customer Service Window
Mail Stop <u>RCE</u>
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir:

This Request for Continued Examination under 37 C.F.R. 1.114 and this amendment are filed in reply to the final Office Action mailed on June 30, 2008. In response thereto, please consider the following remarks.